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PATENT  
Atty. Dkt. No. AMAT/2801.P11/PPC/ECP/RKK

OCT 15 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed: February 16, 2001

For:  
E R

**INTEGRATED SEMICONDUCTOR  
SUBSTRATE BEVEL CLEANING  
APPARATUS AND METHOD**

OK TO ENTER  
AMENDMENT

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Group Art Unit: 1763

Examiner: **Sylvia MacArthur**

**CERTIFICATE OF FACSIMILE TRANSMISSION UNDER  
37 CFR 1.8**

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703-872-9308 to the attention of the named Examiner, on the date below.

10/15/04 Kent J. Davis  
Data Signature

Dear Sir.

RESPONSE TO FINAL OFFICE ACTION DATED AUGUST 18, 2004

In response to the Final Office Action dated August 18, 2004, having a shortened statutory period for response set to expire on November 18, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/2601.P11/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Office. Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.